

Notice of References Cited	Application/Control No. 10/037,447	Applicant(s)/Patent Under Reexamination EGAN ET AL.	
	Examiner Cybille Delacroix-Muirheid	Art Unit 1614	Page 1 of 1


U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	HCAPLUS, DN:128:147502, Toba et al., JP 10007709, (1998), abstract only for JP 10-7709.
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	X	 12-12-05

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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